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UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,425
Filing Date February 8, 2002
Confirmation No. 1727
Inventor Terry L. Gilton et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Thanhha S. Pham
Attorney's Docket No. MI22-1828
Customer No. 021567
Title: Semiconductor Processing Method Using Photoresist and an Antireflective
Coating

RESPONSE TO OCTOBER 18, 2004 NOTICE OF ALLOWANCE
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

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*Entered
w/ RCE
11-2-04
Amir
5-18-05*

Responsive to the Notice of Allowance dated October 18, 2004, Applicant
amendments and remarks as follows:

AMENDMENTS